



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED

JAN-9 2002

TC 3700 MAIL ROOM

In re application of

Shozo OGURI et al.

Serial No. 09/764,318

Filed January 19, 2001

POLISHING APPARATUS

: Docket No. 2001-0046A

: Group Art Unit 3723

: Examiner Berry, Willie W., Jr.

: Confirmation No.

RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents,
Washington, D.C.

Sir:

**THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975**

This is in response to the Restriction Requirement mailed December 5, 2001.

Applicants, by their undersigned representative, hereby elect the invention of Group I which is drawn to a polishing apparatus and corresponds to claims 1-6. This election is made without traverse.

Having made the required election, a full examination on the merits of the elected invention is hereby requested.

Respectfully submitted,

Shozo OGURI et al.

By:

Joseph M. Gorski

Joseph M. Gorski
Registration No. 46,500
Attorney for Applicants

JMG/adb
Washington, D.C. 20006-1021
Telephone (202) 721-8200
Facsimile (202) 721-8250
January 7, 2002